

EURIPIDES Forum 2010 in Paris

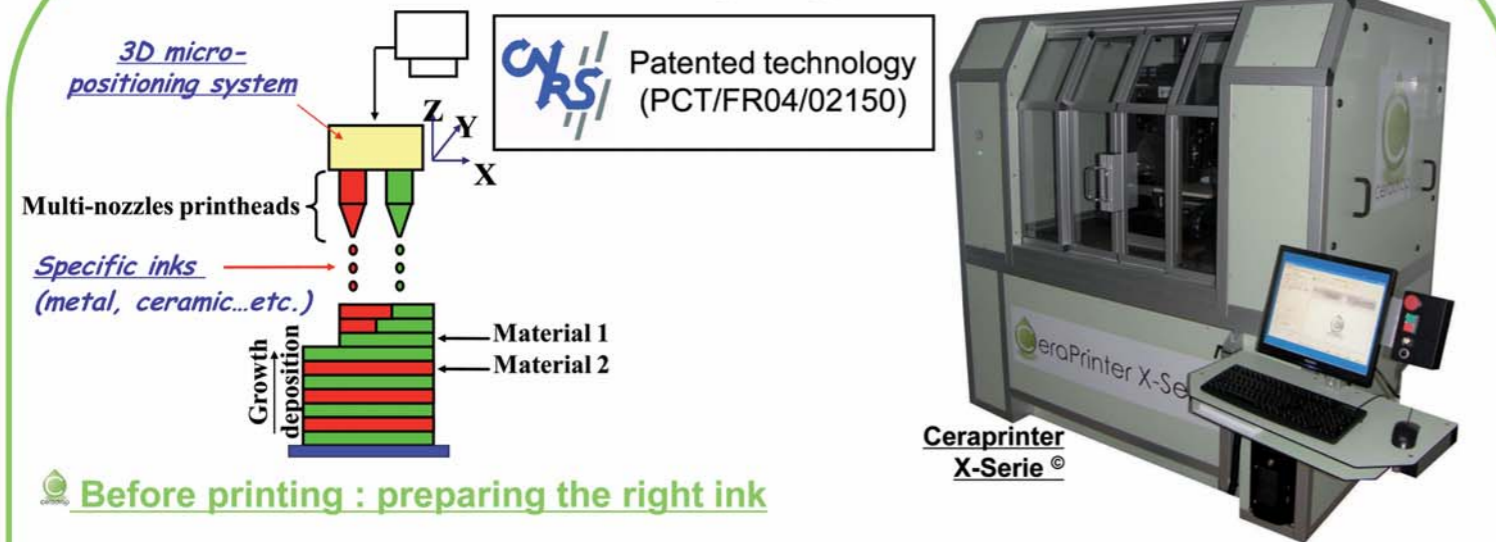
September 30th – October 1st, 2010 in Paris

CeramJet

Ceramic electronic components by inkjet printing

Ceradrop (Limoges – France) ; CMAC (Ronse – Belgium) ; Egide (Bollène – France) ; Eurofarad (Chanteloup-en-Brie – France) ; Heraeus (Hanau – Germany) ; SPCTS (Limoges – France)

Ink-Jet Printing : generalities



Before printing : preparing the right ink

- Choose the right powder according to the targeted application
 - conduction, insulative, properties
 - sintering temperature
 - ...
- Adjust particle size to avoid nozzle clogging ⇒ milling step
 - Raw powder
 - Milled powder
- Adjust dispersant nature and concentration for each powder to avoid powder settlement
 - Bad Ink
 - Good Ink
- Introduce the right additives to adjust :
 - quality of ejection,
 - droplet spreading,
 - layer drying,
 - printed part mechanical properties

Reynolds $Re = \frac{\rho \cdot r \cdot v}{\eta}$ Weber $We = \frac{\rho \cdot r \cdot v^2}{\gamma}$

$$1 < \frac{Re}{\sqrt{We}} = \frac{\sqrt{\gamma \cdot \rho \cdot r}}{\eta} < 10$$

A software adapted to all the applications: CeraSlice

- ✓ Slicing software
- ✓ High level of flexibility and freedom in printing parts
- ✓ Specific tools for MLCC components
- ✓ Convenient for experimental designs in fabrication

- Design 3D component
 - MLCC
 - Thick films
 - HTCC
- Select every parameters for each material
 - Printing head information
 - Calculated fabrication parameters
 - Ink information
 - Filling strategy
- Component slicing
 - HTCC
 - MLCC
 - Ceramic
 - Metal
 - Thick film
- Simulator check
- Actions addition
 - on a single layer
 - between 2 layers

Main Results

MLCC

Progressive fabrication without moving the sample

- Ceramic cover
- First electrode
- Internal dielectric layers
- Second electrode

- Automatic change of printhead for use of both inks
- High precision for electrode printing : 120 μm margins respect

Complete component : 15 electrodes

Height ≈ 800 μm

After sintering

- ✓ Crack-free parts
- ✓ Straight sides in the 3 dimensions
- ✓ Use of a removable organic substrate ⇒ no binding after sintering
- ✓ Required thicknesses for internal electrodes and dielectric layers are reached

Thick Films

Ag components on dense ceramic substrate

Test Vehicle #1

Test Vehicle #2

Demonstrator

- ✓ Good droplet positioning, excellent repeatability
- ✓ Good line definition
- ✓ About 10 μm thick
- ✓ Reproducible manufacturing
- ✓ Crack-free green and sintered tracks

- ✓ Component 100% solderwetting
- ✓ Good silver adhesion on the substrate
- ✓ Correct conductivity after sintering

HTCC

W/Al₂O₃ tracks

20wt% Al₂O₃

30wt% Al₂O₃

40wt% Al₂O₃

- ✓ Good continuous and crack-free tracks
- ✓ Al₂O₃ ratio ↑ ⇒ no cracks after sintering but substrate torn on the edges
- ✓ Al₂O₃ ratio ↑ ⇒ tracks conductivity ↓ (better when tracks are buried)

W/Al₂O₃ vias filling feasibility

Filled via by W/Al₂O₃

Via on chuck

- ✓ Vias (60 & 200 μm) can be filled by ink jet printing process
- ✓ When substrate taken off the chuck, filled vias stay on the chuck
- ✓ Addition of a removable organic sheet between substrate and chuck

Perspectives

MLCC

- Identify final metal ink
- Control dielectric properties
- Print completely straight parts
- Reach the same results on bigger components
- Develop new functionalities of CeraSlice too allow printing of crack-free big parts.

Thick Films

- Make exactly the same parts as industrial actors today by ink-jet printing
- ⇒ Transfer Ink-Jet Printing process to industry

HTCC

- Work on W/Al₂O₃ formulation (ejection is still too changing in time)
- Electrical characterisation s of other test vehicles
- Sintering trials on other test vehicles
- Enlarge ink formulation so as it can be used for several applications
- Improve vias filling